# Monthly LabAdviser update: 30/8 2013

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| Updated Subject  | Contributor | Link to the update pages |
| **Process2Share**Nothing has been added.**Come on users! You must have made something that is worth showing the other user☺** | **Let me know if you need help to add something to process2Share:** **labadviser@danchip.dtu.dk** | <http://process2share.danchip.dtu.dk/index.php/Main_Page> |
| **Etch rate of low stress nitride in BHF**Has been added. | Eric Jensen @nanotech | [http://labadviser.danchip.dtu.dk/index.php/Specific\_Process\_Knowledge/Etch/Wet\_Silicon\_Oxide\_Etch\_(BHF)#Silicon\_oxide\_etch\_data](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Etch/Wet_Silicon_Oxide_Etch_%28BHF%29#Silicon_oxide_etch_data) |
| **Electroplating-Ni**Equipment page has been madeStandard processes have been added. | Claus Højgård Nielsen @danchip | <http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Thin_film_deposition/Electroplating-Ni><http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Thin_film_deposition/Deposition_of_Nickel/Electroplating_of_nickel> |
| **Polymer Injection Molder**Equipment page has been made. | Claus Højgård Nielsen @danchip | <http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Back-end_processing/Polymer_Injection_Molder> |
| **Ellipsometer VASE**Equipment page for ellipsometer VASE (new ellipsometer) has been added. | Berit G. Herstrøm@ danchip | <http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Characterization/Optical_characterization#Ellipsometer> |
| **BHF**Comparing the different BHF baths – look also at the lower half of the page. | Karen Birkelund @danchip | [http://labadviser.danchip.dtu.dk/index.php/Specific\_Process\_Knowledge/Etch/Wet\_Silicon\_Oxide\_Etch\_(BHF)](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Etch/Wet_Silicon_Oxide_Etch_%28BHF%29) |
| **KOH**Updated comparison of the KOH baths. | Karen Birkelund @danchip | <http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Etch/KOH_Etch> |